

Docket No.: 050099-0238



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Shigenobu MAEDA, et al.	:	Confirmation Number: 6603
	:	
Application No.: 10/748,273	:	Group Art Unit: 2823
	:	
Filed: December 31, 2003	:	Examiner: Than V. Pham
	:	

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING IMPURITY
REGION UNDER ISOLATION REGION (As Amended)

AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowance dated September 21, 2005, please amend the
above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this
paper.

Remarks begin on page 10 of this paper.